



PATENT APPLICATION AF/12814

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of

Sunichi SEKI et al.

Group Art Unit: 2814

Application No.: 09/423,969

Examiner: A. Mai

Filed: November 17, 1999

Docket No.: 104741

For: METHOD OF FORMING THIN FILM PATTERNING SUBSTRATE INCLUDING FORMATION OF BANKS (AS AMENDED)

3/18/03
Notice
of
appeal
March
3/8/03

**NOTICE OF APPEAL TO THE BOARD OF PATENT APPEALS
AND INTERFERENCES AND PETITION FOR EXTENSION OF TIME**Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Applicants hereby appeal to the Board of Patent Appeals and Interferences from the Decision of the Primary Examiner dated September 13, 2002.

The \$320.00 Appeal Fee (\$160.00 Small Entity) is:

 Enclosed (our Check No. 140110) Not required (fee paid in prior appeal in this application with no Board Decision on the merits).The shortened statutory period having expired December 13, 2002, it is hereby requested that the period for response be extended for a THIRD month. Included in our enclosed check is \$520.00 in payment of the fee for a THIRD month extension of time for filing this Notice of Appeal. (Payment of \$410.00 for a TWO month extension was already made.)

The Director is hereby authorized to charge any fees which may be required or credit any overpayment to Deposit Account No. 15-0461. Two duplicate copies of this document are enclosed.

Respectfully submitted,

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JAO:MB/jfl

Date: March 13, 2003

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